

| Application/Control No. | Applicant(s)/Patent under Reexamination |
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| 10/088,995 | KASHIWA ET AL. |
| Examiner | Art Unit |
| Caixia Lu | 1713 |

| SEARCHED | | | |
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| Subclass | Date | Examiner | |
| 3486 172 | 9-14-05 | CL | |
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| INTERFERENCE SEARCHED | | | | |
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| Class | Subclass | Date | Examiner | |
| 526 | 348.6 | 9-14-05 | CL | |
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| SEARCH NOTES (INCLUDING SEARCH STRATEGY) | | |
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